

FIG. 2

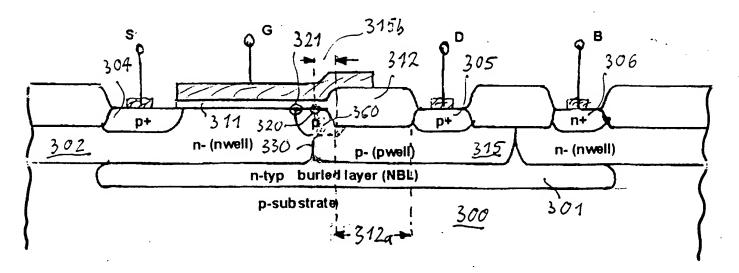


FIG. 3

400

Providing a well of a first conductivity type, operable as the extension of the transister drain of the first conductivity type and covered by a first insulator having a first thickness, and a well of the apposite conductivity type, intended to contain the transister source of the first conductivity type and covered by a second insulator thinner than the first insulator the first and second wells forming a junction that terminates

403 - Depositing a photorerist layer over the

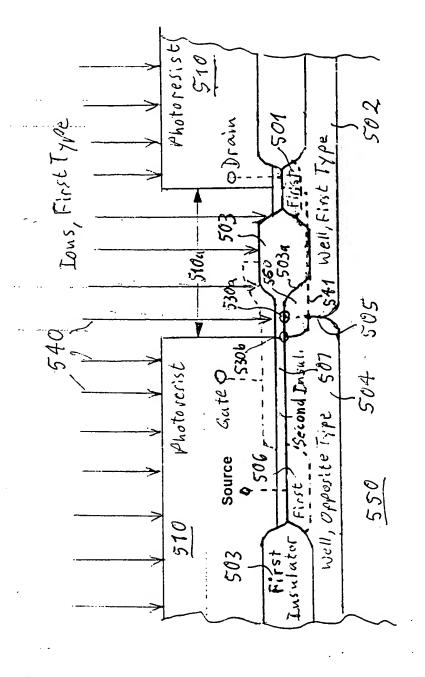
at the second in sulator

Patterning the phatoresist layer by opening a window laterally extending from the drain to the junction termination

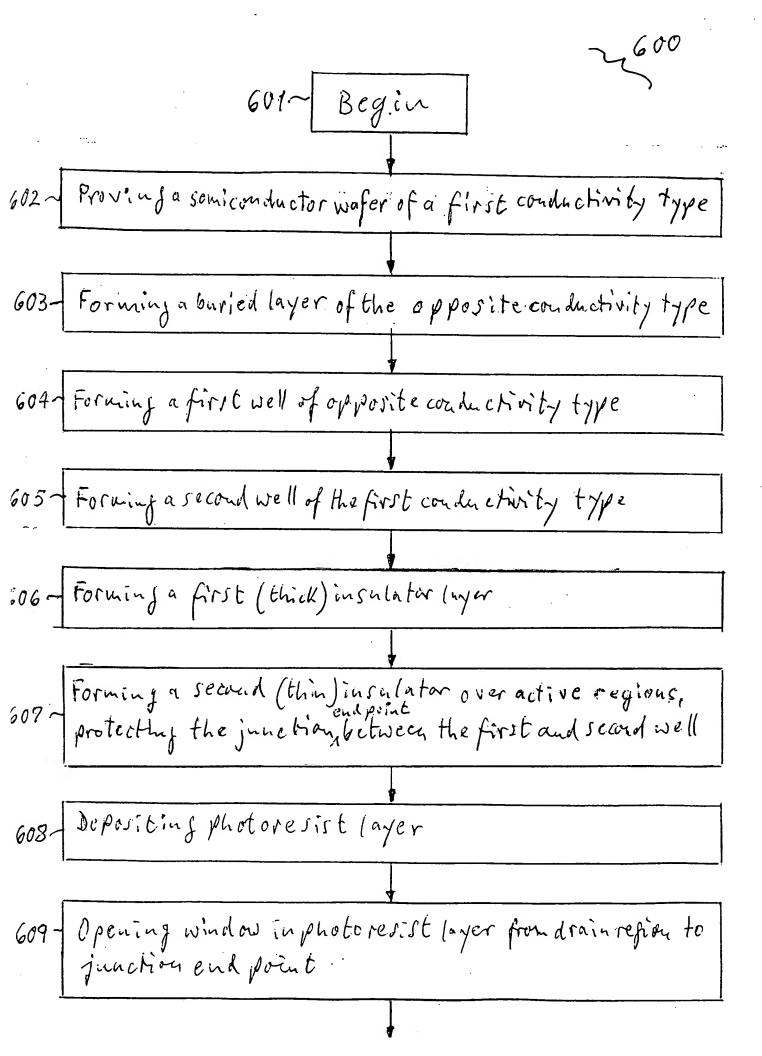
Implanting ions of the first conductivity type through thewindow into the first well the ions having an energy to limit the penetration to the first insulator thickness, and a dose to create a well region of high do ping concentration adjacent to the junction termination

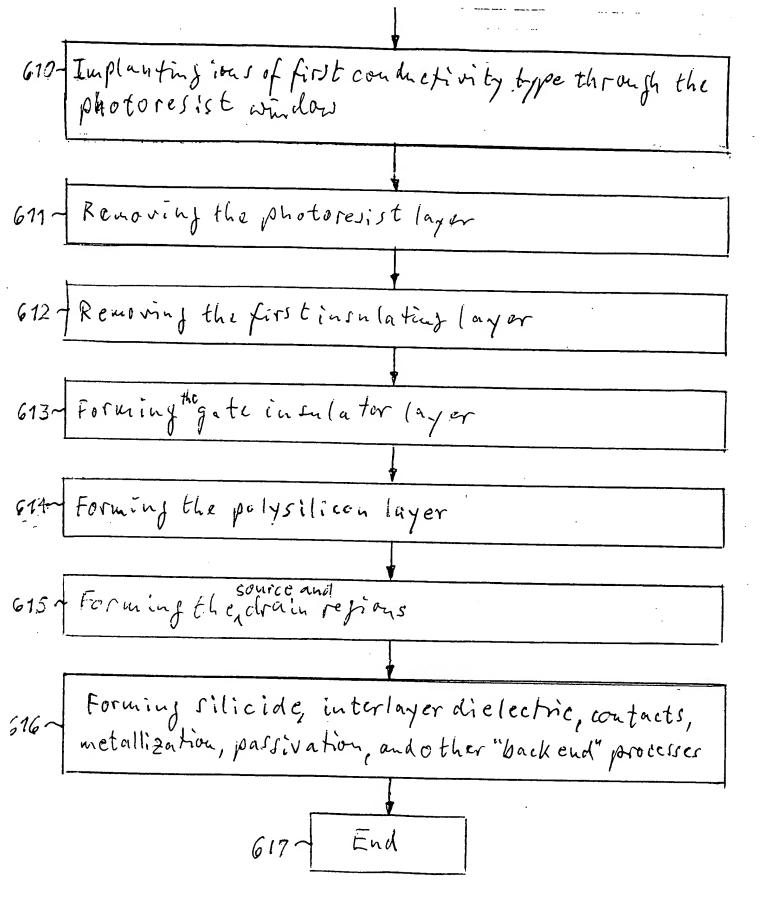
406 - End

FIG. 4

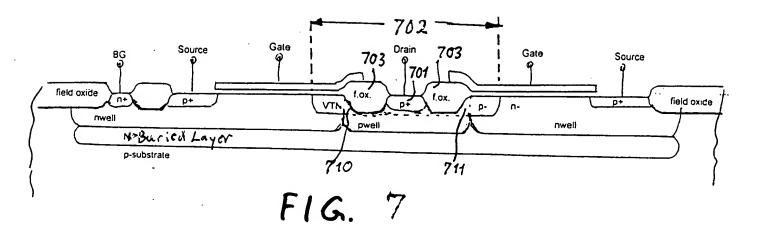


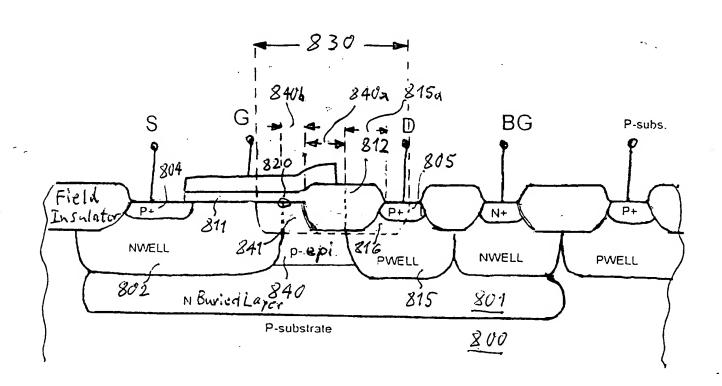
F1G.5





F1G. 6





F1G. 8

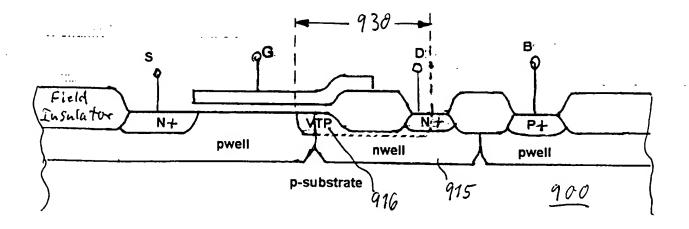


FIG. 9

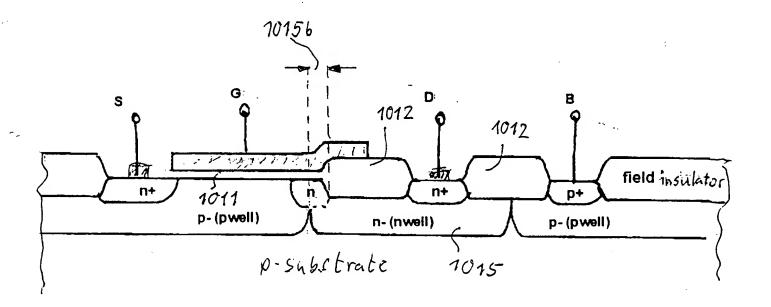


FIG. 10